

Amendments to the Specification:

Please delete the Title and replace with the following new title:

METHODS OF FABRICATING FLUID EJECTION DEVICES

Please replace the Abstract with the following new Abstract:

In one example embodiment, a method of fabricating a fluid ejection device is provided. The method can including fabricating a thinfilm structure on a device substrate and forming a peripheral break trench structure in a first surface of the substrate circumscribing a region in which a feed slot is to be formed through the substrate. Subsequently the substrate can be abrasively machined from a second surface of the substrate to the break trench structure to form the feed slot.